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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/389,533
Priority Filing Date September 2, 1999
Inventor Alan R. Reinberg
Assignee Micron Technology, Inc.
Priority Group Art Unit 2823
Priority Examiner T. Pham
Attorney's Docket No. MI22-1952
Title: Methods of Forming Capacitors and Resultant Capacitor Structures

INFORMATION DISCLOSURE STATEMENT

References -- See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation application of co-pending application Serial No. 09/389,533, filed September 2, 1999, upon which the above-identified application relies for a priority date under 35 U.S.C. §120. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. §1.98(d) and MPEP §609(2). As a courtesy, Applicant submits copies of the cited references for review.

Citation of these references is respectfully requested.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Owen M. Fliegel".

Date: Feb. 22, 2002

Frederick M. Fliegel, Ph.D.
Reg. No. 36,138

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1952	SERIAL NO.		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Alan R. Reinberg			
				FILING DATE	GROUP 2823		
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Lee</i>	AA	6,150,211	11/21/00	Zahurak			
<i>Lee</i>	AB	5,981,333	11/09/99	Parekh et al.			
<i>Lee</i>	AC	5,905,280	05/18/99	Liu et al.			
<i>Lee</i>	AD	5,338,700	08/16/94	Dennison et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AL						Yes
	AM						No
	AN						
	AO						
	AP						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
	AT						
EXAMINER	<i>Bruce Ming Lee</i>			DATE CONSIDERED	<i>4/9/03</i>		
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

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